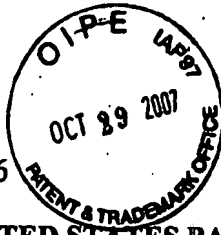


Docket No.: 043890-0746



**PATENT**

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IFD

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Tomohisa TENRA, et al.

RESPONSE UNDER 37 CFR 1.116  
**EXPEDITED PROCEDURE**

Application No.: 10/537,298

Filed: June 02, 2005

Customer No.: 53080  
Confirmation No.: 8367

Group Art Unit: 1772

Examiner: Alexander Thomas

Title: VACUUM HEAT INSULATOR AND ITS MANUFACTURING METHOD

OK. to send  
AW

**RESPONSE UNDER 37 CFR 1.116**

Mail Stop After Final  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This response is filed in response to the Final Office Action dated August 16, 2007.

Remarks begin on page 2 of this paper.